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标题: Sub-THz radiation room temperature sensitivity of long-channel silicon field effect transistors

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摘要: Room temperature operating n-MOSFETs (n-type metal-oxide silicon field effect transistors) used for registration of sub-THz (sub-terahertz) radiation in the frequency range $\nu = 53\text{-}145 \text{ GHz}$ are considered. n-MOSFETs were manufactured by 1- μm Si CMOS technology applied to epitaxial Si-layers (d approximate to 15 μm) deposited on thick Si substrates ($d = 640 \mu\text{m}$). It was shown that for transistors with the channel width to length ratio $W/L = 20/3 \mu\text{m}$ without any special antennas used for radiation input, the noise equivalent power (NEP) for radiation frequency ν approximate to 76 GHz can reach NEP similar to $6 \times 10^{-10} \text{ W/Hz}^{(1/2)}$. With estimated frequency dependent antenna effective area S_{est} for contact wires considered as antennas, the estimated possible noise equivalent power NEP_{pos} for n-MOSFET structures themselves can be from similar to 15 to similar to 10(3) times better in the spectral range of ν similar to 55-78 GHz reaching NEP_{pos} similar to $10^{-12} \text{ W/Hz}^{(1/2)}$.

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